



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/484,421 Confirmation No. : 9681
Applicant : Martin DUBS, et al.
Filed : January 18, 2000
TC/A.U. : 1745
Examiner : Gregg Cantelmo
Docket No. : 080310.48561
Customer No. : 23911
Title : Sputter Chamber as Well as Vacuum Transport Chamber
and Vacuum Handling Apparatus with Such Chambers

AMENDMENT

Mail Stop 313(c)
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted along
with a Petition To Withdraw Application From Issue under 37 C.F.R. §1.313.

Amendments to the Claims are reflected in the listing of claims which
begins on page 2 of this paper.

Remarks begin on page 3 of this paper.